

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:) Group Art Unit: 2826
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Kaoru Koike, et al.) Examiner: Erdem, Fazli
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Application No. **10/080,104**)
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Filed: **February 21, 2002**)
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For: MASK-MAKING MEMBER AND ITS)
PRODUCTION METHOD, MASK AND ITS)
MAKING METHOD, EXPOSURE PROCESS,)
AND FABRICATION METHOD OF)
SEMICONDUCTOR DEVICE)
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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN RESPONSE TO SEPTEMBER 21, 2006 OFFICE ACTION

Dear Sir:

This Amendment is filed in response to the non-final Office Action mailed September 21, 2006. In view of the amendments and remarks made herein, Applicants respectfully request reconsideration and allowance of the pending claims.